

Docket No.: 52352-785



PATENT

*Handwritten:* 10/13  
7/11/03

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

George Jonathan KLUTH, et al.

Serial No.: 10/071,207 ✓

Group Art Unit: 2822

Filed: February 11, 2002

Examiner: GUERRERO, Maria F.

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH  
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE  
CONTACTS

**AMENDMENT**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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JUN - 2 2003  
TECHNOLOGY CENTER 2800

Sir:

These amendments and remarks are being filed in response to the Office Action  
dated March 31, 2003.

This response is being filed in accordance with the Waiver of 37 C.F.R. § 1.121  
pursuant to the Pre-OG Notices of January 31, 2003.